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<b>TRANSMITTAL FORM</b>  (to be used for all correspondence after initial filing)	Application Number	10/669,671
	Filing Date	September 23, 2003
	First Named Inventor	Neal R. Rueger
	Art Unit	2812
	Examiner Name	Unknown
Total Number of Pages in This Submission	Attorney Docket Number	MI22-2145

ENCLOSURES (Check all that apply)		
<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Drawing(s)	<input type="checkbox"/> After Allowance Communication to TC
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm Name	Wells St. John P.S.	
Signature		
Printed name	Jennifer J. Taylor, Ph.D.	
Date	April 4, 2005	Reg. No. 48,711

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EV549571510



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. .... 10/669,671  
Filing Date ..... September 23, 2003  
Inventorship ..... Neal R. Rueger et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... Unknown  
Attorney's Docket No. .... MI22-2145  
Title: Methods of Filling Gaps and Methods of Depositing Materials Using High  
Density Plasma Chemical Vapor Deposition

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art are not included (1276 Off. Gaz. Pat. Off 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated:

April 4, 2005

By:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

Substitute for form 1449/PTO

(Use as many sheets as necessary)

Sheet	1	of	2
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Application Number	10/669,671
Filing Date	September 23, 2003
First Named Inventor	Neal R. Rueger
Art Unit	2812
Examiner Name	Unknown
Attorney Docket Number	MI22-2145

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Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>		<b>Complete if Known</b>	
		Application Number	10/669,671
		Filing Date	September 23, 2003
		First Named Inventor	Neal R. Rueger
		Art Unit	2812
		Examiner Name	Unknown
Sheet 2	of 2	Attorney Docket Number MI22-2145	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		NGUYEN S V: "High-Density Plasma Chemical Vapor Deposition of Silicon-Based Dielectric Films for Integrated Circuits" IBM Journal of	
		Research and Development, IBM Corporation, Armonk, US, vol. 43, no. 1/2, January 1999, pp. 109-126.	

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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